

DOCKET NO: 214144US8



#8/ELB.
6/18/3
Junker

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

NAOKI TSUKIJI ET AL.

GROUP: 2813

SERIAL NO: 10/014,507

EXAMINER: L. SCHILLINGER

FILED: DECEMBER 14, 2001

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT, AND
SEMICONDUCTOR ELEMENT MANUFACTURED WITH THIS METHOD

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

RECEIVED
JUN 13 2003
TECHNOLOGY CENTER-28000

SIR:

In response to the Restriction Requirement dated May 12, 2003, Applicants provisionally elect Group I, Claims 1-36, directed to a method of making a semiconductor device, and elect Species I, Claims 1-16, without traverse.

Accordingly, full examination on the merits of Claims 1-16 is requested.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Bradley D. Lytle
Attorney of Record
Registration No. 40,073
Edwin D. Garlepp
Registration No. 45,330



22850

Tel. No.: (703) 413-3000
Fax No.: (703) 413-2220
BDL:EDG:eac